



1FW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Sheu et al.

Serial No.: 10/619,114

Filed: July 14, 2003

For: Narrow Width Effect Improvement  
With Photoresist Plug Process and  
STI Corner Ion Implantation

Group Art Unit: 2823

Examiner: Brewster, William M

Confirmation No. 6852

TKHR Docket No.: 252016-1300  
Top-Team Ref. 0503-9540US

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop Amendment; Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on June 17, 2004.

  
Signature - Hui Chin Barnhill

**AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

The Office Action mailed May 17, 2004, has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.